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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/081,971	02/20/2002	Shunpei Yamazaki	07977-303001	2205
26171 7590 02/07/2008 FISH & RICHARDSON P.C. P.O. BOX 1022			EXAMINER	
			MULPURI, SAVITRI	
MINNEAPOLIS, MN 55440-1022			ART UNIT	PAPER NUMBER
		·	2812	
			MAIL DATE	DELIVERY MODE
			02/07/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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*	Application No.	Applicant(s)	-
	10/081,971	YAMAZAKI ET AL.	
Office Action Summary	Examiner	Art Unit	
	Savitri Mulpuri	2812	
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet w	ith the correspondence address	
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory perions a failure to reply within the set or extended period for reply will, by state that the provision of the mail of the provision of the mail of the provision of the mail of the provision of the prov	DATE OF THIS COMMUNI 1.136(a). In no event, however, may a od will apply and will expire SIX (6) MON tute, cause the application to become Al	CATION. reply be timely filed  NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).	•
Status			
1)⊠ Responsive to communication(s) filed on 12	July 2007.		
2a) This action is <b>FINAL</b> . 2b) ⊠ Th	his action is non-final.		
3) Since this application is in condition for allow	vance except for formal mat	ters, prosecution as to the merits is	
closed in accordance with the practice under	r <i>Ex parte Quayle</i> , 1935 C.[	), 11, 453 O.G. 213.	
Disposition of Claims		•	
4) Claim(s) <u>20,33-54 and 57-64</u> is/are pending	in the application.		
4a) Of the above claim(s) is/are withd	rawn from consideration.		
5)⊠ Claim(s) <u>20 and 51-54</u> is/are allowed.			
6)⊠ Claim(s) <u>33-50, 57-64</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and	I/or election requirement.	·	
Application Papers		·	
9)☐ The specification is objected to by the Exami	ner.		
10) The drawing(s) filed on is/are: a) a	ccepted or b) objected to	by the Examiner.	
Applicant may not request that any objection to the			
Replacement drawing sheet(s) including the corre			
11) The oath or declaration is objected to by the	Examiner. Note the attache	d Office Action of form PTO-192.	
Priority under 35 U.S.C. § 119		•	
12) Acknowledgment is made of a claim for foreignal All b) Some * c) None of:	gn priority under 35 U.S.C.	§ 119(a)-(d) or (f).	
<ol> <li>Certified copies of the priority docume</li> </ol>	ents have been received.		
2. Certified copies of the priority docume		• •	
3. Copies of the certified copies of the pr	·	received in this National Stage	
application from the International Bure	· · · · · · · · · · · · · · · · · · ·	received	
* See the attached detailed Office action for a li	st of the certified copies hot	received.	
Attachment(s)		•	
1) Notice of References Cited (PTO-892)	4) Interview	Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(	(s)/Mail Date Informal Patent Application	
3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 11/21/2007.	6) Other:		

#### **DETAILED ACTION**

This action is in response to the applicant's communication filed on 7/23/2007.

### Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 33-50, 57-64 are rejected under 35 U.S.C. 102(e) as being Jung et al (US 2002/0018912 A).

Jung et al teaches a method of depositing a layer for electroluminescent device: Jung teaches successively forming a first function region comprising hole transportation layer of first organic compound on an electrode, organic emission layer and organic electron transportation layer. Jung et al specifically teaches simultaneous irradiation of ultraviolet light generated by lamp during deposition, wherein ultraviolet light having wavelength in the range of 100-200nm or 254 nm to 320 nm to result compact film formation (fig.2 and related description and para0062). Jung et al teaches direction of irradiation is from the same direction of evaporating of the first and second organic compound, wherein evaporation source from which the first organic compound is evaporated is differ rent from a evaporation source from which the second organic compound is evaporated, and wherein first organic compound source is evaporated

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from first evaporation source and second organic compound is evaporated from second evaporation source (see fig. 1 and related description). Jung also discloses light source, first evaporation source and second evaporation source are all in same plane (see para0036-0039, para0077. Jung et al clearly discloses simultaneous deposition of more than two organic compounds in vacuum deposition chamber, which inherently results mixed region of first organic compound and second organic compound, which is essential for making efficient electroluminescent devices giving emission at desired wave lengths (see para 0036 - para 0039, para0076-0077 and claim 9).

Jung et al specifically teach forming an organic thin film by simultaneous deposition of organic compound A and organic compound B and simultaneous irradiation by means of vacuum deposition (fig.1), wherein the organic thin film prepared by polymerization of the compound formula 1 having at least one acetylene group. Jung et al also teach forming electroluminescent device can have hole transportation layer, emission layer and electron transport layer (fig2), wherein transportation layer or emission layer formed by depositing at least one compound in formula 1, which suggest that transportation layer or emission layer can have at least one organic compound A or B or together, which satisfy the instant claimed process.

With respect to new claims 57,61 Jung et al inherently discloses the mixed region through irradiation with to form a compacted mixed region comprising the first organic compound and second organic compound because uses UV irradiation and using the first compound and second compound to form mixed region. Jung et al, teaches forming organic electroluminescent device by depositing similar compounds such as Alq 3 to

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form emission layer or transport layer (para 0026, 0076) as similar to the instant invention (page, 35, line 9). Jung et al teaches ultraviolet irradiations give curing (polymerization), which is similar to the instant invention. Unless the organic compounds are different in the instant invention from the invention of Jung et al, the result i.e., forming mixed region is same in both Jung et al and instant invention because both Jung et al and instant invention uses first and second organic compounds along with UV radiation for forming hole transpiration layer and emission layer.

Also, in forming electroluminescent organic devices, the emission layer is a grading organic layer with mixed organic compounds, which are used to form hole transportation layer and electron transportation layer, see for evidence Fig. 1 layers 29, 31, 30 in So et al (US 5, 925,980).

. With respect to claims 58-60, 62-64 Jung et al teaches the wavelength of the UV radiation is 254 nm - 300 nm. (Para 0062)

. Claims 20, 51-54 are allowed.

## Response to Arguments

Applicant's remarks filed on 11/21//2007have been noted. Applicant argue that Jung does not describe or suggest (1) mixed region comprising a mixture of first and second organic compounds during irradiation with light in the deposition chamber as

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recited in claims 33 and 44, but only teaches formation polymer film by simultaneous deposition of two or more organic compounds, where polymer is different from mixture... However, as agreed by applicant Jung uses simultaneous deposition of two or more organic compounds by using UV light irradiation and it is irrelevant whether the organic compound molecules are giant or small molecule to form polymer layer or small molecular layers respectively. Since claims are limited to mixed region comprising first organic compound and second organic compound, Jung teaches mixed region with simultaneous deposition of first and second organic compounds by using UV light irradiation for making organic electroluminescent layers and it is inherent in the invention of Jung et al results mixed region of first organic compound and second organic compound (see para 0036, last three lines). Jung et al, teaches forming organic electroluminescent device by depositing similar compounds such as Alq 3 to form emission layer or transport layer (para 0026, 0076) as similar to the instant invention( page, 35, line 9). Jung et al teaches ultraviolet irradiations give curing (polymerization), which is similar to the instant invention. In Jun et al the two different organic compounds get mixed first and then polymerized due to laser irradiation

So is shown to see how intermixed region is helpful to improve the efficiency of the OLED. So teaches intermixed region between hole transport and electron transport layer result smooth interface and improves the efficiency of the device. So is merely applied to show the advantage of intermixed region for the device. So is shown as evidentiary document how the emission layer is a grading organic layer with mixed

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organic compounds, which are used to form hole transportation layer and electron transportation layer, see for evidence Fig. 1 layers 29, 31, 30 in So et al (US 5, 925,980).

Applicant argues that (2) Jung does not teach activating organic compound molecules, thereby forming compact organic film as mentioned in the instant invention (para 0063-00630. Since Jung teaches forming mixed region with simultaneous deposition of first and second organic compounds by irradiation of laser with wavelength 254-300 nm, Jung inherently forms compact organic film because similar materials are treated with similar process in both instant invention and Jung et al.

### Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

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the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Savitri Mulpuri whose telephone number is 571-272-1677. The examiner can normally be reached on Mon-Fri from 8 a.m. to 4.30 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael, Lebentritt, can be reached on 571-272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Primary Examiner Art Unit 2812